

RECEIVED
CENTRAL FAX CENTER
APR 07 2006

S/N 10/757,864

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	KITAOKA ET AL.	Examiner:	SONG
Serial No.:	10/757,864	Group Art Unit:	1722
Filed:	January 15, 2004	Docket No.:	10873.1391US01
Title:	METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE		

CERTIFICATE UNDER 37 CFR 1.6(d)

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on April 7, 2006.

By: Gina M. Dahl
Name: Gina M. Dahl

CHANGE OF CORRESPONDENCE ADDRESS

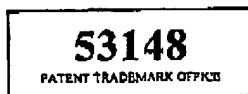
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

Please change the correspondence address for the above-referenced patent application to:

Hamre, Schumann, Mueller & Larson, P.C.
P.O. Box 2902-0902
Minneapolis, MN 55402

If there are any questions regarding this matter, please call the undersigned at 612.455.3800.

Dated: April 7, 2006

Respectfully submitted,

HAMRE, SCHUMANN, MUELLER &
LARSON, P.C.
P.O. Box 2902-0902
Minneapolis, MN 55402-0902
(612) 455-3800

By: Douglas P. Mueller
Reg. No. 30,300
DPM/gmd